	Application No.	Applicant(s)
Notice of Allowability	10/788,941	FARNWORTH ET AL.
	Examiner	Art Unit
	Hae M. Hyeon	2839
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313 1. This communication is responsive to Amendment filed on 2	ears on the cover sheet wit (OR REMAINS) CLOSED in or other appropriate commu GHTS. This application is s and MPEP 1308.	th the correspondence address this application. If not included unication will be mailed in due course. THIS
3. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	been received. been received in Application cuments have been received of this communication to file ENT of this application.	n No If in this national stage application from the a reply complying with the requirements
 CORRECTED DRAWINGS (as "replacement sheets") mus (a) ☐ including changes required by the Notice of Draftspers 	t be submitted. on's Patent Drawing Review	
1) ☐ hereto or 2) ☐ to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the state of the sheet of the state of the sheet.	84(c)) should be written on th	ne drawings in the front (not the back) of
 DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F 		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit	6. ☐ Interview Su Paper No./l 8), 7. ☐ Examiner's	formal Patent Application (PTO-152) Jummary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allowance
of Biological Material	9. 🗌 Other	Hae Moon Hyeon HAE MOON HYEON PRIMARY EXAMINER

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REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance: In combination with all the limitations recited in the independent claim, all the prior arts do not show a contact comprising a polymer (or dielectric material) core having a conductive coating on at least a portion of the core. Claims 1 and 95 recite that the core protrudes from a semiconductor device component in a generally transverse orientation to a plane of the semiconductor device component. Claim 116 recites that the core is secured to and protruded from a contact pad of the semiconductor device component.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hae M. Hyeon whose telephone number is 571-272-2093. The examiner can normally be reached on Mon.-Fri. (8:30-5:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tulsidas C. Patel can be reached on (571) 272-2098. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hae M Hyeon Primary Examiner Art Unit 2839

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Hae Moon Hyeon